



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 8563

SERIAL NUMBER 10/738,360	FILING DATE 12/16/2003  RULE	CLASS 438	GROUP ART UNIT 2891	ATTORNEY DOCKET NO. LMRX-P029/P1180
-----------------------------	---------------------------------------	--------------	------------------------	---

## APPLICANTS

Yu Cheng, Fremont, CA;

Helen Zhu, Fremont, CA;

Vinay V. Phoray, Fremont, CA; Hanzhong Xiao, Pleasanton, CA;

Peter K. Loewenhardt, Pleasanton, CA;

\*\* CONTINUING DATA \*\*\*\*\* *NONE CUME*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *NONE CUME*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/27/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 7	TOTAL CLAIMS 24	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	EXAMINER'S SIGNATURE <i>C. Loewenhardt</i>	INITIALS <i>CUME</i>		
Verified and Acknowledged				

## ADDRESS

32986

IPSG, P.C.

P.O. BOX 700640

SAN JOSE, CA

95170-0640

## TITLE

Methods and apparatus for the optimization of photo resist etching in a plasma processing system

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
RECEIVED		